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Bib Data Sheet

SERIAL NUMBER 09/631,830	FILING DATE 8/03/2000 RULE -	CLASS 257	GROUP ART UNIT 2835	ATTORNEY DOCKET NO. 1701.00021
APPLICANTS Yusuke Kohyama, Yokosuka-Shi, JAPAN; takashi Ohsawa, Yokohama-Shi, JAPAN; Shizuo Sawada, Urawa-Shi, JAPAN;				
** CONTINUING DATA ***** <i>qhm</i> THIS APPLICATION IS A DIV OF 08/720,032 09/27/1996 PAT 6,130,450				
** FOREIGN APPLICATIONS ***** <i>qhm</i> JAPAN 7-254218 09/29/1995 → in parent				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/26/2000.				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met-after met Verified and <i>SB Malsan</i> Acknowledged Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 13	TOTAL CLAIMS 10
INDEPENDENT CLAIMS 2				
ADDRESS 22907				
TITLE Stacked capacitor-type semiconductor storage device and manufacturing method thereof				
FILING FEE RECEIVED 1080	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	